



PATENT  
Atty. Dkt. No. AMAT/3976.P1/CMP/CMP/RKK

1763  
J

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Emami, et al.

Serial No.: 09/727,133

Confirmation No.: 2919

Filed: November 29, 2000

For: Planarized Copper Cleaning for  
Reduced Defects

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

§ Group Art Unit: 1763

§ Examiner: George A. Goudreau

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CERTIFICATE OF MAILING

37 CFR 1.8

I hereby certify that this correspondence is being deposited on  
October 31, 2003, with the United States Postal Service as  
First Class Mail in an envelope addressed to: MAIL STOP  
NON-FEE AMENDMENT Commissioner for Patents, P.O. Box  
1450, Alexandria, VA 22313-1450.

10/31/03  
Date

Kurt J. Huber  
Signature

**RESPONSE TO OFFICE ACTION DATED AUGUST 1, 2003**

In response to the Office Action dated August 1, 2003, having a shortened statutory period for response set to expire on November 1, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/3976.P1/KMT, for any fees, including extension of time fees in excess of the petition above, or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks/Arguments** begin on page 11 of this paper.